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APPLICANTS

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** CONTINUING DATA ***** NONE SWC

** FOREIGN APPLICATIONS ***** SWC
 JAPAN P2002-305330 10/21/2002
 JAPAN P2003-092737 03/28/2003

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Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 18	TOTAL CLAIMS 36	INDEPENDENT CLAIMS 5
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Verified and Acknowledged
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TITLE
 Semiconductor wafer and a method for manufacturing a semiconductor wafer

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)
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